

Docket No.: 4425-320

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :

Chien-Hsin LAI et al. :

U.S. Patent Application No.: *Not Yet Assigned* :

Filed: *Herewith* :

For: PLASMA APPARATUS AND METHOD CAPABLE OF ADAPTIVE IMPEDANCE
MATCHING

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Preliminary to examination of the above-referenced application, please amend the application as follows:

Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application: